

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/790,220	OKAZAKI ET AL.	
Examiner	Art Unit	
Richard H. Kim	2871	

SEARCHED					
Class	Subclass	Date	Examiner		
349	111,117	5/9/2005	RHK		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner.		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East Search	5/9/2005	RHK	